

Notice of References Cited	Application/Control No. 10/064,483	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Jaric Loving	Art Unit 2137	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,525,599 A	06-1985	Curran et al.	713/190
*	B	US-5,267,311 A	11-1993	Bakhoun, Ezzat G.	705/56
*	C	US-5,450,489 A	09-1995	Ostrover et al.	705/51
*	D	US-5,467,396 A	11-1995	Schossow et al.	713/193
*	E	US-5,860,094 A	01-1999	Junya, Tempaku	711/5
*	F	US-6,401,208 B2	06-2002	Davis et al.	713/193
*	G	US-2002/0174353 A1	11-2002	Lee, Shyh-shin	713/193
*	H	US-2003/0014653 A1	01-2003	Moller et al.	713/193
*	I	US-6,546,489 B1	04-2003	Frank et al.	713/187
*	J	US-6,615,355 B2	09-2003	Mattison, Phillip E.	713/193
*	K	US-2003/0204754 A1	10-2003	Cromer et al.	713/202
*	L	US-2004/0003274 A1	01-2004	Strom et al.	713/193
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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